Isolators, Polarizers, and Other Optical Waveguide Devices Using a Resonant-Layer Effect

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Abstract—This paper investigates the effect of a high-refractive-index layer added onto the clad layer of an optical waveguide. With proper design, the value of the fundamental mode’s confinement factor in the added layer can exhibit a resonance. This resonance depends on the added layer’s location, thickness, complex index, and wavelength of operation. If loss is incorporated into this added layer, relatively small changes in waveguide properties can result in large changes in loss. This phenomenon is referred to in this paper as the resonant-layer effect (RLE). A number of devices, including isolators, polarizers, and modulators, can be made and/or improved by using the RLE. As examples, this paper describes an integratable isolator giving 240-dB/cm isolation and 13-dB/cm insertion loss, a 90-dB/cm rejection and 13-dB/cm isolation and 240-dB/cm isolation.

Index Terms—Integrated optics, magnetooptic Kerr effect, modulation, optical isolators, optical polarizers.

I. INTRODUCTION

A SECOND peak of the fundamental mode can appear in a high-refractive-index layer added onto or within the clad of an optical waveguide. The overall waveguide loss can be dominated by the loss in the added layer and used to selectively suppress guided modes. This effect may be used to enhance the operation of a number of optical waveguide devices. The appearance of the secondary field peak in conjunction with the suppression of secondary guided modes is sensitive to the location, refractive index, loss, and thickness of the added layer and to the wavelength of operation. This phenomenon is called the resonant-layer effect (RLE).

A number of devices, including isolators, polarizers, modulators, gratings, feedback reflectors, and gratings, can be made and/or improved by using the RLE. The appearance of RLE generally results in relatively high modal loss. Since the RLE is sensitive to the physical characteristics of the waveguide, relatively small changes in waveguide properties can result in large changes in loss. This RLE concept is easily integrated into any optical waveguide.

The RLE is similar to a resonance effect observed in channel-substrate-planar (CSP) lasers that accidentally had a nonuniform Al composition in the channel [1].

Many useful devices rely on changes in modal loss. Isolators result from loss changes with propagation direction. Amplitude modulators result from loss changes in response to a physical input such as an electric or magnetic field. A space-periodic change in loss results in a diffraction grating. In polarizers, the loss changes with polarization.

For example, a transverse electric (TE) mode may show a strong RLE and thus have a large secondary peak in the resonant layer (RL), while a transverse magnetic (TM) mode of the same structure will have no secondary peak in the RL, giving rise to a polarization-sensitive filter. A number of examples of how RLE gives rise to useful devices are given hereafter.

Briefly, to obtain the RLE, a relatively high-index layer (usually containing loss) is deposited on or within the clad layer of an optical waveguide, which is referred to here as the RL, or resonant layer. The real part of the refractive index of the RL must be higher than that of the clad. In this case, at the correct thickness, and for the correct range of the complex index of the RL, a secondary peak of the modal field will exist in the RL. This means that a substantial fraction, in some cases \( \approx \) 25\%, of the guided-mode intensity is confined to the RL. Under these conditions, small changes in the propagation constant of the guided mode will result in large changes in the confinement factor of the RL. The waveguide modal propagation constant may be changed in several ways.

1) There can be a polarization change. This leads to a polarizer.
2) There can be a change in propagation direction in conjunction with an RL made from ferromagnetic materials, which, in the presence of a magnetic field, show magneto optic effects (Faraday/Kerr effect). This leads to an isolator that may be integrated with a wide variety of material systems. As a corollary, varying an applied magnetic field can result in modulation.
3) There can be a change in applied electric fields in conjunction with an RL or other layers that exhibit electrooptic effects such as the Pöckel’s effect. This leads to intensity modulation.
4) There can be a change in the wavelength. Here, the loss layer acts as a wavelength filter.
5) Finally, there can be a periodic spatial variation of the thickness (or complex index) of the RL itself. In this case,
the amplitude of the resulting grating can be greatly magnified. A grating period chosen to outcouple radiation can increase the loss of the RL. An RL also allows flexibility in the placement of gratings in waveguides.

Phase-matched waveguides cited in the literature are commonplace. Directional couplers/modulators are examples [2]. Despite this, to the authors’ best knowledge, the exploitation of the secondary field peak in one “subwaveguide” when the other “subwaveguide” is excited [3] has not been exploited in the manner described in this paper. Specifically, if sufficient loss is added to the RL, the secondary peak has significant amplitude over a limited thickness and index range, in contrast to the loss-free case in which the amplitude of the secondary peak may increase monotonically with RL thickness until the RL becomes the principle guide.

II. THEORY AND METHOD OF FINDING THE REQUIRED THICKNESS OF THE RL TO OBSERVE THE RLE

The appearance of a secondary peak may be understood by considering the fields of the two separate three-layer waveguides in Fig. 1(a) and (b), and the field of the composite five-layer waveguide in Fig. 1(c). If the two waveguides are in close proximity [Fig. 1(c)], they become subwaveguides of the composite waveguide. Although the fundamental mode of the composite waveguide will have energy distributed in both subwaveguides, if the waveguides are dissimilar, then typically, there is little energy in the secondary waveguide and most of the energy in the primary waveguide. Conversely, if the subwaveguides are identical, the energy is equally distributed between them.

By considering the transverse wave vectors that correspond to each subwaveguide, we can understand how to obtain a significant secondary peak in one of the subwaveguides. If the thickness and index of the secondary waveguide [layer 2 in Fig. 1(c)] is appropriately chosen, maximum energy is transferred between the two subwaveguides. Layer 2 can be crudely viewed as an “antireflective” coating that allows the traveling waves corresponding to the transverse wave vectors in layer 4 to penetrate into both layers 2 and 1, thereby maximizing the secondary field peak. Of course, the exact thickness and index value of layer 2 depends on the thicknesses and indexes of all five layers.

Based on this physical model, the correct thickness range of the RL may be found by the following method (note that to obtain the secondary peak, the real part of the complex refractive index of the RL must be greater than that of the cladding layer on which the RL is deposited, and lowest order planar waveguide modes are assumed). First, take the primary waveguide to be a three-layer planar waveguide consisting of an infinitely thick substrate and a cover layer with a refractive index equal to that of the clad $n_C$ and a guide layer with index $n_G$ and thickness $t_G$ equal to those of the device under study. Find the effective index ($N_G$) of the lowest order mode of this waveguide. Then, consider the secondary waveguide to be an asymmetric-three-layer-planar guide [Fig. 1(a)] consisting of a substrate made of the same material as the clad layer of the device, a high-index layer with refractive index equal to the real part of the RL layer $n_{RL}$, and air or vacuum as the upper layer. Calculate the effective index for this planar waveguide ($N_{RL}$) as a function of the RL thickness $t_{RL}$. The value of $t_{RL}$ at which $N_{RL} = N_G$ will be close to the optimum required for the RLE. If no match is found, then RLE will not be obtained. In this case, the thickness or other parameters of the principle guide may be varied to achieve the desired match. A similar calculation can be done for cases in which the RL is covered with a low-index layer other than air. This would be the case if the RL were “buried” in cover material.

A second method to estimate the thickness range of the RL is to calculate the cutoff thickness $h$ of the lowest order mode for the asymmetric planar waveguide [Fig. 1(a)] and consider thicknesses where $h < t_{RL} < 2h$ and where $h$ is found from the formula [4]

$$h = \left[ \frac{\Delta}{\left(n_{RL}^2 - n_C^2\right)^{1/2}} \right] \tan^{-1}(a^{1/2}), \quad (1)$$

where $a$ is given by

$$a = a_{(TE)} = \frac{\left(n_{RL}^2 - 1\right)}{\left(n_{RL}^2 - n_C^2\right)} \quad (2)$$
TABLE I
WAVEGUIDE LAYERS FOR A POLARIZER

<table>
<thead>
<tr>
<th>Material</th>
<th>Loss, $\alpha$ (cm$^{-1}$)</th>
<th>Refractive Index</th>
<th>Thickness ($\mu$m)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Air</td>
<td>0.0</td>
<td>1.0</td>
<td>-</td>
</tr>
<tr>
<td>Resonant Layer</td>
<td>$4.0 \times 10^2$</td>
<td>1.54</td>
<td>$t_{RL}$ = 0.63, $h = 0.619$</td>
</tr>
<tr>
<td>Polymer with dye</td>
<td></td>
<td></td>
<td>$t_{RL}$ = 0.76, $h = 0.714$</td>
</tr>
<tr>
<td>Quartz (p-) clad</td>
<td>0.0</td>
<td>1.447</td>
<td>4.0</td>
</tr>
<tr>
<td>Doped quartz core</td>
<td>0.0</td>
<td>1.452</td>
<td>10.0</td>
</tr>
<tr>
<td>Quartz Substrate</td>
<td>0.0</td>
<td>1.447</td>
<td>-</td>
</tr>
</tbody>
</table>

Waveguide layers for a polarizer using a simple quartz-based waveguide with a BP Polymer RL [6] containing an absorbing dye. The cutoff thickness $h = 0.619$ (TE) and $h = 0.714$ (TM), giving a ratio of $t_{RL}/h = 1.02$ (TE), 1.06 (TM).

for TE modes, and

$$a = a_{(TM)} = a_{(TE)} n_F^{4/3} \cdot (3)$$

for TM modes.

$n_{RL}$ is the real part of the refractive index of the RL, which is considered to be the guiding layer for the purpose of this cutoff calculation. $n_C$ is the refractive index of the clad layer, which is considered to be the substrate for the purpose of this cutoff calculation. $n_F$ is the ratio of $n_{RL}$ to the refractive index of the lowest index clad layer (air, in this case).

Generally, the optimum thickness can be further refined by calculating the maximum confinement factor ($\Gamma_{RL}$) of the RL layer as a function of the RL thickness for the wavelength and polarization mode considered. This may be done using well-known analytic means or software such as MODEIG/WAVEGIDE [5]. The $t_{RL}$ value at which $\Gamma_{RL}$ is maximized is close to the optimum thickness for the device in question. In doing this calculation, one usually avoids solutions where the RL becomes the dominant guiding layer.

The thickness of the clad, $t_C$, influences the value of $\Gamma_{RL}$ and has a secondary influence on the optimum thickness of the RL. In many cases, $t_C$ is chosen so that $\Gamma_{RL}$ is less than about 0.25, which implies that less than 25% of the field intensity is confined to the RL. Finally, the loss of the RL is chosen to maximize modal loss while still maintaining the fundamental mode of the complete waveguide. The peak-resonant wavelength may be tuned by changing the thickness of the RL.

III. RLE POLARIZERS

Consider the waveguide structure illustrated in Fig. 2. A high-index layer with loss is applied on top of the clad layer of a waveguide consisting of undoped and doped quartz layers (similar to layers used in optical fibers). In this example, the RLE will result in a polarizer and broad-band wavelength filter. Each layer of this waveguide is listed in Table I. The RL is a polymer, such as perfluorocyclobutyl polymer plastic [6], containing a dye that has modest absorption in the 1.55-$\mu$m wavelength region and is placed as the RL of the waveguide shown in Fig. 2. Near-field intensities illustrating the secondary peak for the lowest order TE and TM modes are plotted in Fig. 3(a) and (b) at a wavelength of 1.55 $\mu$m and an RL loss of $\alpha_{RL} = 400$ cm$^{-1}$. In Fig. 3(a), at an RL thickness $t_{RL} = 0.76 \mu$m a strong secondary peak in the loss layer

1A revised version of the software described in [5] is available at http://engr.smu.edu/ee/smuphotonics/Modeig.htm
occurs for the TM mode, and there is no peak for the TE mode. Here, maximum absorption of the lowest order TM mode takes place. In Fig. 3(b) where \( t_{RL} = 0.63 \mu \text{m} \), the secondary peak occurs for the TE mode, which will result in maximum absorption of this mode. In both figures, the thickness of the cladding layer \( t_C \) is 4.0 \( \mu \text{m} \).

The effect of these secondary peaks on the modal transmission is illustrated in Fig. 4, which shows the insertion loss as a function of the RL thickness. The solid line is for the TE mode. The dashed line is for the TM mode. At \( t_{RL} = 0.63 \mu \text{m} \), the TE shows maximum absorption, while at \( t_{RL} = 0.76 \mu \text{m} \), the TM mode shows maximum absorption. The absorption passes through a maximum as the thickness of the RL is increased. This reflects the magnitude of the secondary peak that also passes through a maximum as the thickness is varied. For each polarization mode, \( t_{RL} \) is slightly larger than the cutoff thickness \( t_{C} \) of the center layer of the secondary three-layer waveguide calculated as described in Section II.

There is a limited range of RL absorption values over which such “resonant” secondary peaks may be observed, and a maximum value of modal (insertion) loss, which is illustrated in Fig. 5. Fig. 5 shows both the insertion loss and confinement factor of the TE mode at \( \lambda = 1.55 \mu \text{m} \) as a function of layer thickness. In this case, the maximum RLE giving rise to the highest insertion loss occurs at an RL loss \( \alpha_{RL} \approx 220 \text{ cm}^{-1} \). At this peak value of insertion loss, the confinement factor is still very close to its maximum value that occurs at zero layer loss. In this plot, the RL thickness \( t_{RL} \) is chosen to give strong TE absorption. The TM insertion loss is below 3 dB/cm over the loss range plotted, as suggested by Fig. 4. Similar behavior is observed if the thickness is chosen to give strong TM absorption. In general, there is an optimum value of RL loss, which maximizes the modal (or insertion) loss for each particular device.

Fig. 6(a) is a plot of the insertion loss for both the \( TE_0 \) and \( TM_0 \) modes as a function of wavelength for \( t_{RL} = 0.76 \mu \text{m} \) and an RL loss of 220 cm\(^{-1}\). The strong absorption of the TM mode (\( \approx 140 \text{ dB/cm} \)) and the weak absorption of the TE mode (\( \approx 1 \text{ dB/cm} \)) is the behavior of a TE polarizer. Fig. 6(b) is a similar plot for \( t_{RL} = 0.63 \mu \text{m} \). This case illustrates a good and rather broad-band TM polarizer with 90-dB/cm absorption of the TE mode and a very weak absorption of the TM mode (0.82 dB/cm). Thus, the RLE can be used to make an efficient polarizer and wavelength filter. The thickness of the clad \( t_C \) is chosen according to the discussion in Section II.
IV. ISOLATORS USING THE RLE

An isolator may be obtained if the RL in Fig. 2 is made from a ferromagnetic material. Isolators with useful isolation and low forward insertion loss are produced when the RLE is present. As explained in detail hereafter, the same arrangement acts as an isolator absent the RLE, but with much higher forward insertion loss, resulting in poor performance [7].

A biasing magnetic field \( H(\pm) \) applied in the lateral \((y)\) direction results in a nonreciprocal change of the complex propagation constant of a TM-like guided mode due to the magnetooptic Kerr effect [7]–[9]. Thus, the loss for guided light traveling in the \(+z\) direction is different than the loss in the \(-z\) direction, resulting in an isolator. Reversing the propagation direction is equivalent to reversing the direction of the applied field. Hence, we use the notation of \( H(+) \) to represent propagation in the forward direction and \( H(−) \) to represent propagation in the reverse direction. An isolator using Faraday rotation in a metal-ferromagnetic film requires a more complex structure and suffers from high loss [10].

A ferromagnetic–semiconductor composite (FSC) RL can consist of nanometer-size ferromagnetic particles distributed throughout a semiconductor host. The composites may be generated by epitaxial growth [11] or by ion implantation followed by annealing [12]. Such FSC layers can be used with semiconductor waveguides and integrated optic material systems. The optical loss of a composite consisting of nanometer-size-ferromagnetic particles in an FSC layer or in a plastic host material is reduced compared with a continuous ferromagnetic layer containing the same weight of ferromagnetic material, while the Faraday rotation and, hence, magnetooptic Kerr effects remains the same [13], [14]. For an FSC layer under bias by a magnetic field and with a thickness in the correct range to support the RLE, the relatively small change in complex refractive index between the positive and negative propagation direction causes the modal field of the waveguide to have a large secondary peak in the FSC layer in the reverse direction. An isolator using Faraday rotation in a multi-quantum-well (MQW) waveguide, \( t_{RL} \approx 0.413 \mu m \), and \( t_C = 3.0 \mu m \) is shown in Fig. 7. For a given composition and choice of waveguide parameters, the required range of the FSC–RL thickness is determined by the waveguide conditions described in Section II.

An isolator example uses an FSC–RL of nanometer-size iron particles in an InGaAsP host within the InP p-cladding of a common 1.55-µm multi-quantum-well (MQW) laser structure as shown in Table II. This isolator can be integrated with a laser or amplifier. InGaAsP has a refractive index of 3.4, which is higher than the refractive index of the InP p-clad, which is 3.1628 at 1.55 µm. These values satisfy the need to have the real part of the refractive index of the FSC–RL greater than that of the p-clad. The cutoff thickness for the FSC–RL is shown in Table III. The volume fraction of Fe in the host is 0.020, and the reduction factor of the imaginary part of the complex refractive index is 1/30 [13].

The values of the complex refractive index and Faraday rotation of iron are obtained from Gaugitsch and Hauser [15], which gives recent values at a wavelength of 1.0 µm. These are adjusted to a wavelength of 1.55 µm using values given in [16]. We thus obtain a complex index for iron at a zero magnetic field of \( n = 3.343 \), \( k = 5.104 \). The Faraday rotation is \( \Theta_F = 650.000°/cm \). The off-diagonal matrix element is given by \( 2n \Theta_F/k \). The Maxwell–Garnet theory [13] applied to a 2% volume fraction of nanometer-sized iron particles in an InGaAsP semiconductor host of index 3.4 results in a complex index of the composite of \( n = 3.4042 \) and \( k = 2.822 \times 10^{-3} \) (which corresponds to loss \( \alpha = 228.8 \text{ cm}^{-1} \) for \( H(+) \) and \( n = 3.3030 \) and \( k = 4.146 \times 10^{-3} \) (which corresponds to a loss \( \alpha = 336.2 \text{ cm}^{-1} \)) for \( H(−) \).

The isolator insertion loss and confinement factor for the FSC–RL at \( \lambda = 1.55 \mu m \) as a function of the RL loss is shown Fig. 8. The RL thickness \( t_{RL} \) and clad thickness \( t_C \) are optimized values of 0.413 and 2.6 µm, respectively. The confinement factor maximum value is 0.247 at zero loss and drops to 0.238 at a loss value of \( \approx 205 \text{ cm}^{-1} \), at which maximum isolation occurs.

The large difference in the amplitude of the secondary-field peak in the FSC–RL results in a large difference in the confinement factor \( \Gamma_{RL} \) for light traveling in opposite directions (Fig. 9). The large difference in \( \Gamma_{RL} \) effectively amplifies the effect of the loss of the RL. In addition, there is a change in the loss of the RL layer associated with the propagation direction due to the magnetooptic Kerr effect (shown in Table II), and the higher modal loss \( \Gamma(−) \) in Fig. 9) corresponds to the higher RL loss (336.2 cm\(^{-1}\)) compared with 228.8 cm\(^{-1}\). The resulting differences between \( \Gamma(+) \) and \( \Gamma(−) \) in the insertion loss of the waveguide mode yield high isolation and low insertion loss.

Fig. 10 shows the isolation and isolation–loss ratio as a function of the FSC–RL thickness. The isolation is the loss in the backward direction in decibels per centimeter. The isolation–loss ratio, which is the ratio of the loss in the backward direction to the loss in the forward direction in decibels per decibel, is also shown.

For an FSC–RL thickness of \( t_{RL} \approx 0.413 \mu m \), the isolation is 240 dB/cm with a forward insertion loss of only 12.7 dB/cm, giving an excellent isolation–loss ratio of 18.9 dB/dB. Thus, a 30-dB isolator could be 1.25 mm in length and have an insertion loss of 1.6 dB.
TABLE II
Layer Structure for an Isolator Using Fe-InGaAsP FSC–RL Deposited on a Typical MQW Structure Using Quaternary Semiconductor Layers

<table>
<thead>
<tr>
<th>Layer Material</th>
<th>Loss, α (cm⁻¹)</th>
<th>Refractive Index</th>
<th>Thickness (μm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Air</td>
<td>0.0</td>
<td>1.0</td>
<td>-</td>
</tr>
<tr>
<td>Fe-InGaAsP FSC (H+)</td>
<td>228.8</td>
<td>3.4042</td>
<td>See text</td>
</tr>
<tr>
<td>Fe-InGaAsP FSC (H-)</td>
<td>336.2</td>
<td>3.3930</td>
<td>See text</td>
</tr>
<tr>
<td>p-clad InP</td>
<td>0.0</td>
<td>3.1628</td>
<td>3.0</td>
</tr>
<tr>
<td>Barrier InGaAsP</td>
<td>0.0</td>
<td>3.37</td>
<td>0.05</td>
</tr>
<tr>
<td>QW InGaAsP</td>
<td>0.0</td>
<td>3.46</td>
<td>0.01</td>
</tr>
<tr>
<td>Barrier InGaAsP</td>
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<td>3.37</td>
<td>0.01</td>
</tr>
<tr>
<td>QW InGaAsP</td>
<td>0.0</td>
<td>3.46</td>
<td>0.01</td>
</tr>
<tr>
<td>Barrier InGaAsP</td>
<td>0.0</td>
<td>3.37</td>
<td>0.01</td>
</tr>
<tr>
<td>QW InGaAsP</td>
<td>0.0</td>
<td>3.46</td>
<td>0.01</td>
</tr>
<tr>
<td>Barrier InGaAsP</td>
<td>0.0</td>
<td>3.37</td>
<td>0.05</td>
</tr>
<tr>
<td>n-clad InP</td>
<td>0.0</td>
<td>3.1628</td>
<td>0.50</td>
</tr>
<tr>
<td>n-substrate InP</td>
<td>0.0</td>
<td>3.1628</td>
<td>-</td>
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</table>

TABLE III
Ferromagnetic–Semiconductor Composite RL Values for Operation at λ = 1.55 μm

<table>
<thead>
<tr>
<th>FSC Type</th>
<th>InGaAsP Host</th>
<th>p-clad n</th>
<th>Thickness h (μm)</th>
<th>tRL (μm)</th>
<th>Max Isolation-Loss Ratio Ls / L(+) (dB/dB)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Fe-InGaAsP</td>
<td>3.4</td>
<td>3.163</td>
<td>2.6</td>
<td>0.22</td>
<td>0.413</td>
</tr>
</tbody>
</table>

V. MODULATORS USING THE RLE

An RL modulator on X-cut LiNbO₃ is illustrated in Fig. 11. A Ti–LiNbO₃-strip guide of width $W_F$ is separated by LiNbO₃ strips of width $W_C$ from two Ti–LiNbO₃ strips of width $W_{RL}$, which are doped to have loss. The doped lossy strips in this symmetric arrangement substitute for the RLs of the planar guides discussed previously. At the correct values of $W_F$, $W_C$, and $W_{RL}$ and their corresponding effective indexes, secondary peaks of the guided intensity fall in the lossy strip regions. The secondary peaks “amplify” the effect of the loss strips. If the secondary peaks are large, the propagating mode has high losses (at resonance), and if the secondary peaks are small (off-resonance), the modal losses are small. The application of a voltage across the electrodes can change the refractive indexes of the strip guide, changing an on-resonance field distribution (with large secondary peaks) to an off-resonance distribution (with small or no secondary peaks), as illustrated by the near-field intensity plots of Fig. 12. The plots are made for a modulator with dimensions: $W_F = 3$ μm, $W_C = 2$ μm, and $W_{RL} = 2.4$ μm. The Ti diffusion depth is assumed to be 5 μm for both the guide and the lossy strips, and the optimum loss in the lossy strips is $\alpha_{RL} = 233$ cm⁻¹. Fig. 8. For $H(\sim)$ biasing magnetic field, insertion loss and FSC–RL confinement factor at $\lambda = 1.55$ μm as function of layer loss for ferromagnetic–semiconductor composite RL.
At $V = -10 \mathrm{V/\mu m}$, the secondary peaks of the field intensity in the loss strip regions are large and at $V = 10 \mathrm{V/\mu m}$, there are no apparent secondary peaks. This example indicates the RLE in a device using strip guides with the effect in the lateral ($y$) direction rather than in the transverse ($z$) direction of the polarizer and isolators discussed previously.

The effective index method was used to calculate the field distributions of this device by solving for the lowest order planar TE modes of a 5-\(\mu\)m-thick layer of Ti–LiNbO$_3$ with and without loss on a LiNbO$_3$ substrate. The real and imaginary parts of the normalized propagation constant in both cases provide the effective refractive index and effective modal loss, respectively. The propagation constant of the TM mode of a planar guide with layers of thickness $W_{RL}$, $W_F$, and $W_{C}$ corresponding to the strips of Fig. 11 and using the appropriate effective values of refractive index and loss is then calculated to find the performance of the modulator. The refractive index [17] and loss values used are listed in Table IV for $\lambda = 1.523 \, \mu\text{m}$. We assume that the material loss $\alpha_{RL}$ does not change with applied voltage.

The insertion loss in decibels and the percent transmitted are plotted against voltage in Fig. 13 for a 300-\(\mu\)m-long device. The insertion loss ranges from 10.8 dB at $-10 \, \mathrm{V/\mu m}$ to 0.87 dB at $+10 \, \mathrm{V/\mu m}$. The transmitted intensity varies from 18.2% to 82% over this range of voltage. For example, with $-3 \, \mathrm{V/\mu m}$ dc bias, a $\pm 5 \, \mathrm{V/\mu m}$ signal across $W_F$ would give a 45% intensity modulation with an insertion loss of less than 7 dB in a device only 300 \(\mu\)m long. The short length minimizes the problem of phase matching between the driving signal and the optical wave. This length is short compared with lengths on the order of several centimeters, which is required by more conventional approaches to high-frequency optical modulators [17], [18].

VI. RLE-ENHANCED DIFFRACTION GRATINGS ON OPTICAL WAVEGUIDES

The sensitivity of the RLE to the thickness of the loss layer suggests fabricating diffraction gratings in such layers. As an example, consider the isolator waveguide structure described previously with layers shown in Table II and the isolation shown in Fig. 10. By forming a second-order outcoupling grating on the RL, the isolation loss can be substantially increased above 240 dB due to radiation with little or no increase in insertion loss.

Another possibility is the use of a low-loss (1–5 \(\mathrm{cm}^{-1}\)) RL that produces a substantial secondary peak. In this case, a shallow grating on the RL at a modest distance from the core can provide very strong feedback or out-coupling compared with a typical grating formed in the cladding layer closer to the core.
TABLE IV  
REFRACTIVE INDEX AND LOSS VALUES USED TO CALCULATE MODULATOR  
PERFORMANCE AT A WAVELENGTH OF 1.523 µm  

<table>
<thead>
<tr>
<th>V/µm</th>
<th>Ti-LiNbO₃ Index</th>
<th>Effective Index</th>
<th>LiNbO₃ Index</th>
</tr>
</thead>
<tbody>
<tr>
<td>-10</td>
<td>2.1563</td>
<td>2.1526</td>
<td>-</td>
</tr>
<tr>
<td>0</td>
<td>2.1583</td>
<td>2.1545</td>
<td>196</td>
</tr>
<tr>
<td>10</td>
<td>2.1603</td>
<td>2.1565</td>
<td>-</td>
</tr>
</tbody>
</table>

![Image](Fig. 13. LiNbO₃ RL modulator: Wₓ = 3 µm, Wᵧ = 2 µm, Wₐ = 2.4 µm, length = 300 µm, and αₑₑₑₑ = 196 cm⁻¹. Wavelength of operation is λ = 1.523 µm.

VII. CONCLUSION

A high-refractive-index layer containing a prescribed thickness and amount of loss added to the cladding layer of an optical waveguide can act to enhance the operation of waveguide polarizers, isolators, modulators, and diffraction gratings. The waveguide loss becomes very sensitive to small changes in waveguide properties because of the appearance of a secondary-field peak in the added RL at the prescribed thickness. This effect is called the RLE. The RLE enhances the isolation and reduces the insertion loss of isolators, increases the polarization ratio and reduces the insertion loss of polarizers, reduces the length of electrooptic modulators, and increases the feedback and out-coupling of diffraction gratings. Polarizers, isolators, filters, and electrooptic-intensity modulators that can be integrated with a variety of material systems and showing excellent properties using the RLE have been described.

Possible dimensions and compositions required to illustrate devices based on the RLE are provided. Although reasonable performance parameters are calculated, no attempt was made to fully optimize these devices.

APPENDIX

In a gyrotropic medium exhibiting the magnetooptic Kerr effect, the relative dielectric tensor can be written as a tensor whose components depend on the direction of an applied magnetic field. In particular, when the static magnetic field is applied in the y direction of a dielectric layer containing the spin-oriented material, the dielectric tensor becomes

\[
\kappa = \kappa_g \begin{pmatrix} 1 & 0 & jQ \\ 0 & 1 & 0 \\ -jQ & 0 & 1 \end{pmatrix} \tag{A1}
\]

where \(\kappa_g\) and \(Q\) are complex quantities associated with the anisotropic layer. In other layers, say the \(i\)th layer, which is assumed to be isotropic, the off-diagonal element \(jQ = 0\) and the relative dielectric constant is \(\kappa_i\).

It is now appropriate to discuss waves in a multilayered dielectric waveguide with mode propagation in the positive \(z\) direction. The relative permittivity will be assumed to be constant in each layer of the structure. For “TE”-polarized fields, the electric field has only a component in the \(y\) direction \(E_y\), while the magnetic field has two components \(H_x\) and \(H_z\). The Maxwell equation that includes the gyrotropic properties is

\[
\nabla \times \mathbf{H} = j\omega \varepsilon_0 \kappa \cdot \mathbf{E}. \tag{A2}
\]

For an electric field polarized along \(y\), the right-hand side (RHS) of (A2) is identical to that for a nongyrotropic medium because the product of the dielectric tensor and electric field has only a component in the \(y\) direction. (The gyrotrropic variable \(Q\) plays no role in the solution of Maxwell’s equation.) Accordingly, the waves behave similar to those in an isotropic material.

The gyrotrropic medium affects the “TM”-polarized waves considerably different than the “TE”-polarized waves. For “TM”-polarized modes, there is only one component of the magnetic field \(H_y\), while the electric field has both \(E_x\) and \(E_z\). Here, the RHS of (A2) couples the \(E_x\) and \(E_z\) components so that

\[
\nabla \times \mathbf{E} = \sqrt[1]{\kappa_g}(E_x + jQF_z) + \sqrt[4]{\kappa_g}(-jQF_x + E_z) \tag{A3}
\]

where \(\hat{x}\) and \(\hat{z}\) are unit vectors in the \(x\) and \(z\) directions, respectively. The wave equation for \(H_y\), found from the two Maxwell curl equations, is

\[
\frac{d^2 H_y}{dx^2} + h_y^2 H_y = 0 \tag{A4}
\]

where the transverse wavenumber of the gyrotrropic medium is

\[
h_y^2 = (\gamma^2 + k^2\kappa_g)(1 - Q^2). \tag{A5}
\]

The magnetic field \(H_y\) and the electric field component \(E_z\) must be continuous at the boundary between the gyrotrotropic material and the surrounding layers. Continuity of the electric field
the transverse wavenumber given by (A5) has

\[ j\omega_0 E_z = \frac{1}{\kappa_g (1 - Q^2)} \left( jQ \gamma H_y + \frac{dH_y}{dx} \right) \]  \quad (A6)

For most practical structures where layers have modest fractional content of gyrotropic materials such as Fe or Co, the value of \( Q \ll 1 \) so that the transverse wavenumber given by (A5) has the form

\[ \frac{d^2}{dy^2} = \gamma^2 + k^2 \kappa_g \]  \quad (A7)

which has the same form as that of an isotropic layer. Hence, the anisotropic behavior of the mode is determined entirely from the flux continuity, (A6), which is now reduced to (first order in \( Q \))

\[ j\omega_0 E_z \approx \frac{1}{\kappa_g} \left( jQ \gamma H_y + \frac{dH_y}{dx} \right) \]  \quad (A8)

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REFERENCES


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